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Signature

(N) RCG/1756

PTO/SB/30 (08-00)
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## REQUEST

FOR

# CONTINUED EXAMINATION (RCE) TRANSMITTAL

Subsection (b) of 35 U.S.C. § 132, effective on May 29, 2000, provides for continued examination of an utility or plant application filed on or after June 8, 1995.

See The American Inventors Protection Act of 1999 (AIPA).

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Application Number	09/975,855
Filing Date	10/11/2001
First Named Inventor	Ren Guey Hsieh
Group Art Unit	1756
Examiner Name	Saleha Mohamedulla
Attorney Docket Number	67,200-447

This is a Request for Continued Examination (RCE) under 37 C.F.F. NOTE: 37 C.F.R. § 1.114 is effective on May 29, 2000. If the above-identified apwish to consider filing a continued prosecution application (CPA) under 37 C.F.R. § 1.5 the patent term adjustment provisions of the AIPA. See Changes to Application Examinated Reg. 50092 (Aug. 16, 2000); Interim Rule, 65 Fed. Reg. 14865 (Mar. 20, 2000), 1 established RCE practice.	pplication was filed prior to May 29, 2000, applicant may 53 (d) (PTO/SB/29) instead of a RCE to be eligible for ination and Provisional Application Practice, Final Rule, 65	ion.
- Anendment/cepty	Brief previously filed on	or
SIGNATURE OF APPLICANT, ATTORNE	<del></del>	
Name (Print Type) RandyW. Tung	Registration No. (Attorney/Agent) 31,311	
Signature	Date 5/10/04	
CERTIFICATE OF MAILING OR TRANSMISSION		
I hereby certify that this correspondence is being deposited with the United States F envelope addressed to: Commissioner For Ratents, Box RCE, Washington, DC 202 Office on:  Name (Print/Type) Kathy Dixon	Postal Service with sufficient postage as first class r 231, or facsimile transmitted to the U.S. Patent and	nail in an Trademark

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Date

67,200-447; TSMC 00-0890 Serial Number 09/975,855

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

TO:

Commissioner for Patents

PO Box 1450

Alexandria, VA 22313-1450

FROM:

Tung & Associates

838 West Long Lake Road - Suite 120

Bloomfield Hills, MI 48302

DATE:

5 May 2004

REF:

Applicant: Hsieh et al.

Filing Date: 11 October 2001

Serial No : 09/975,855

Att'y No. : 67,200-447

Art Unit

: 1756

Examiner : Saleha R Mohamedulla

Title

: Gap Forming Pattern Fracturing Method for Forming Optical

Proximity Corrected Masking Layer

#### AMENDMENT AND RESPONSE FILED WITH RCE

Sir:

In conjunction with the accompanying request for continued examination (RCE), please consider the following amendments and remarks pertaining to the above referenced application.

There are no amendments to the specification or drawings. Amendments to the claims are contained within A Listing of the Claims that begins on page 2 of this paper. Remarks begin on page 8 of this paper.

### **CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being forwarded in an envelope with sufficient postage as first class mail to the Commissioner for Patents, POB 1450, Alexandria, VA

22313-1450 on May

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